responsive environments

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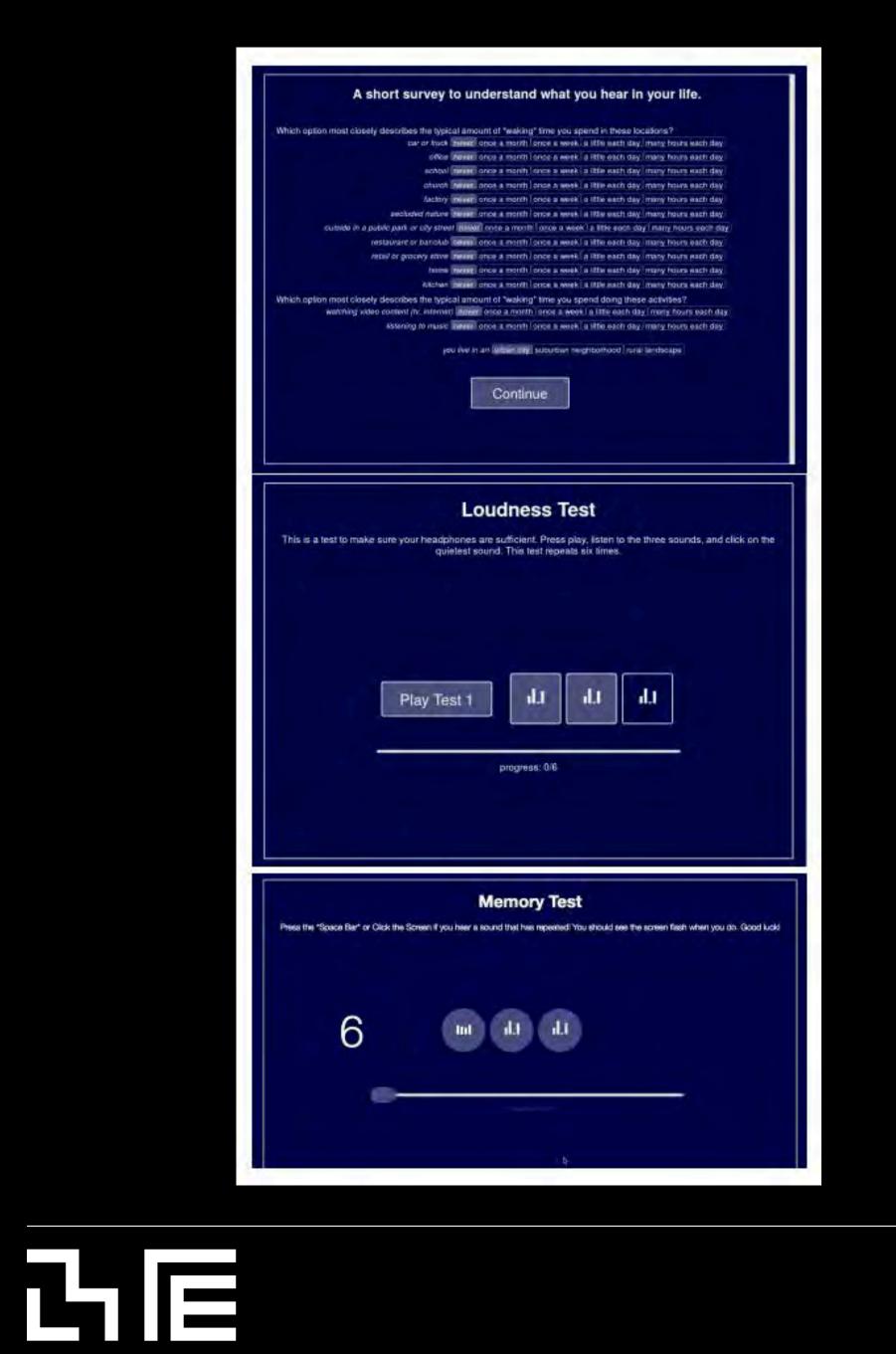
Physiological States + Models of Attention and Behavior

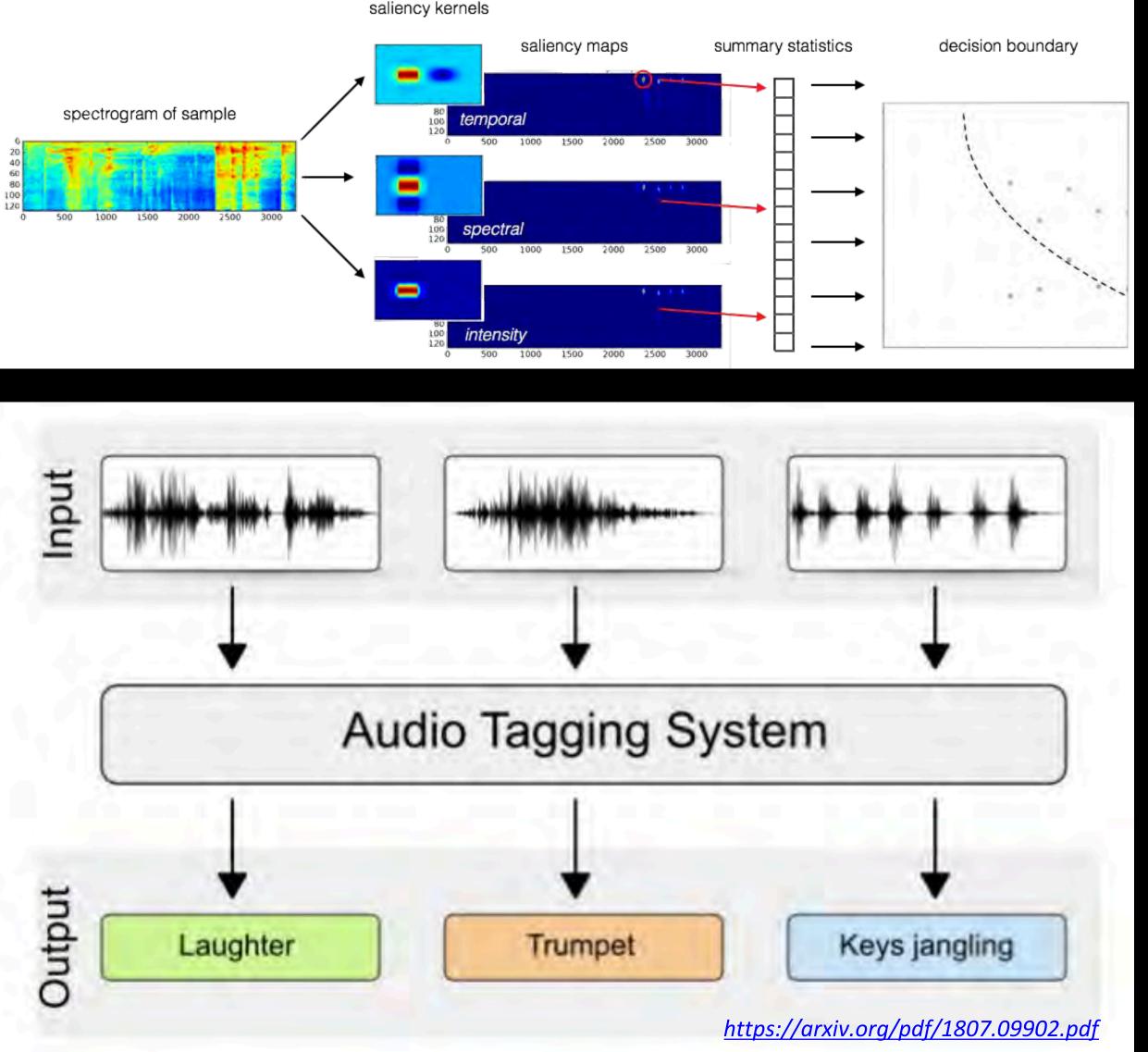
Atmospherics + Objects and Tools

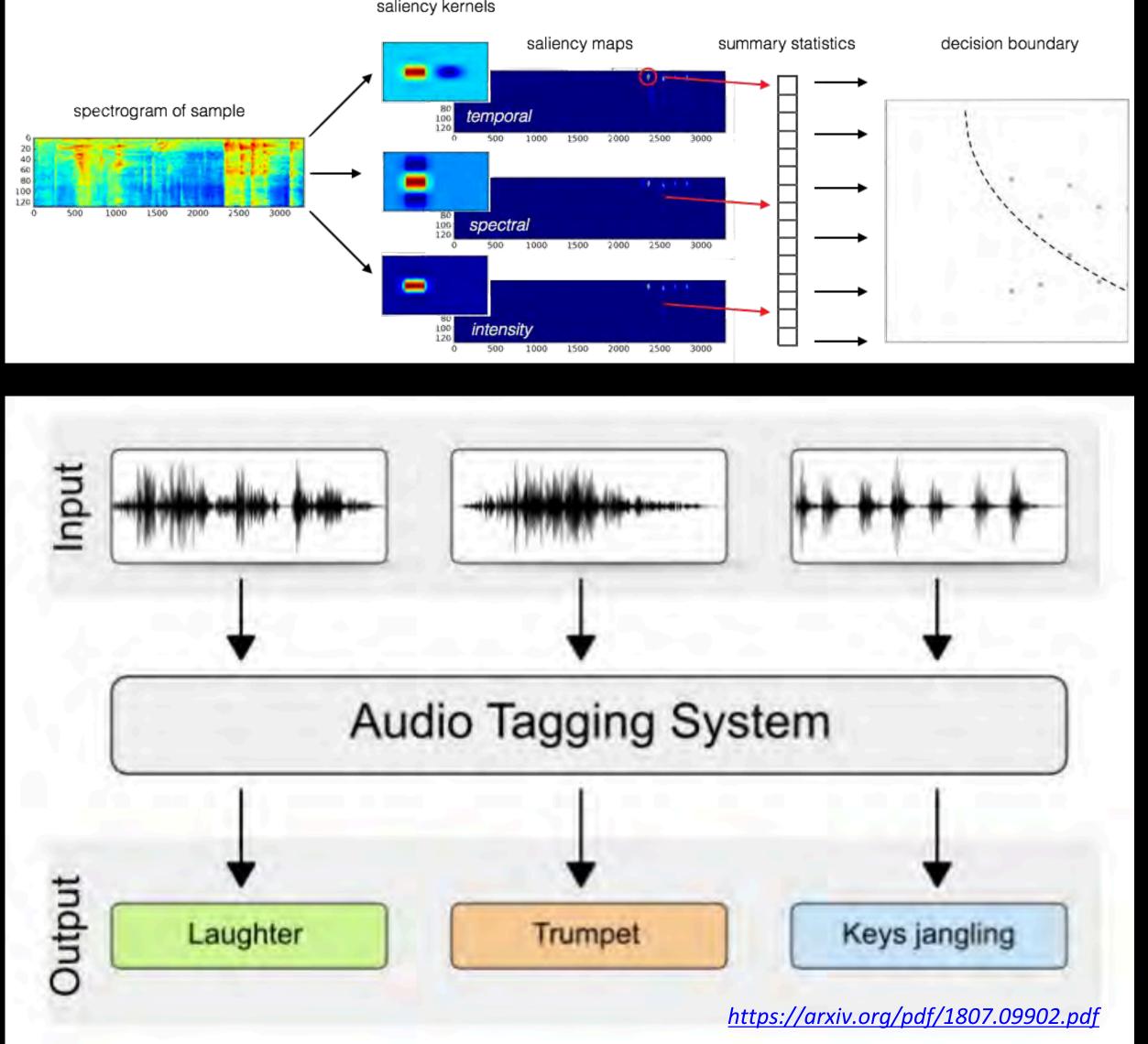


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Ishwarya Ananthabhotla | David Ramsay

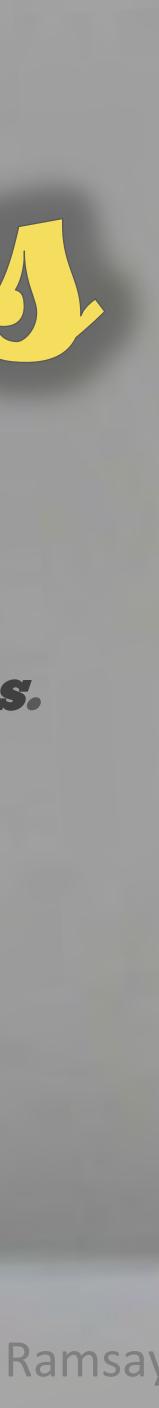




Moving the study of deep attention out of the lab real moments across many contexts and experiences.



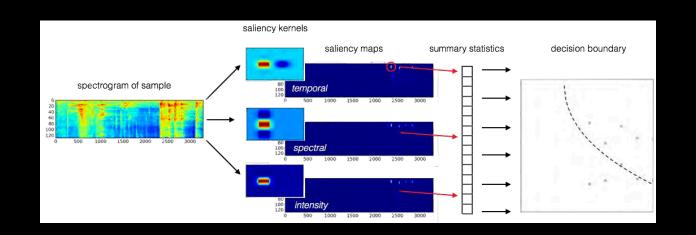
Patrick Chwalek | David Ramsay





Patrick Chwalek | David Ramsay











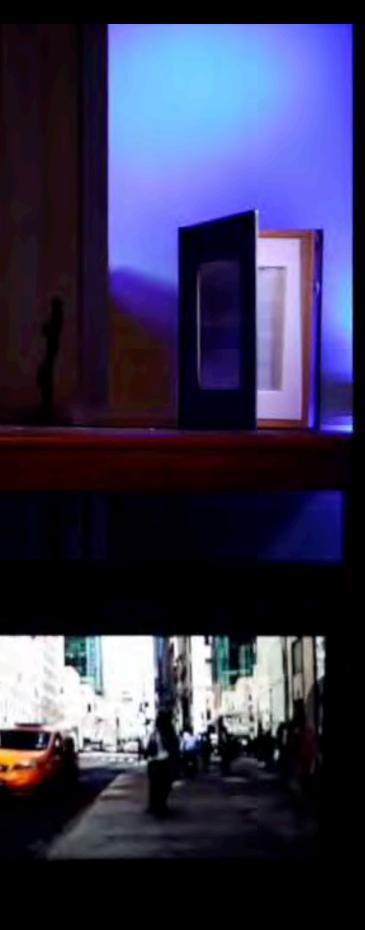
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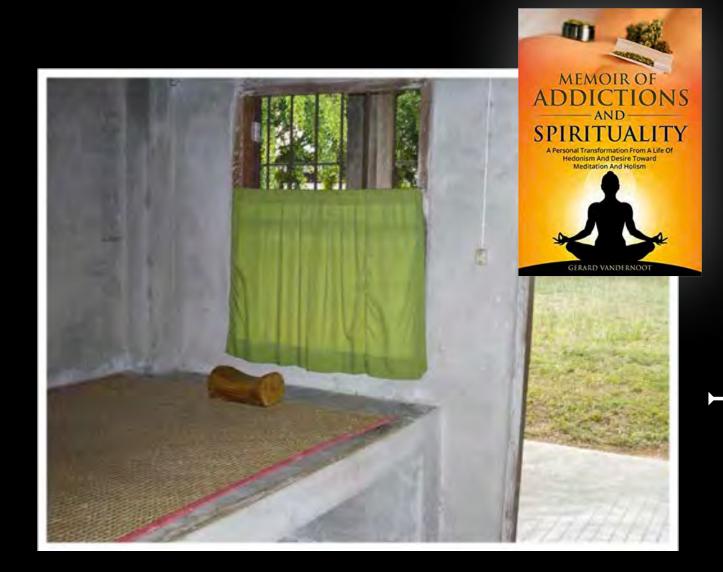


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Ascetic Objects Dispassionate Stoicism





Addictive Objects Impulsive Hedonism

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SensorKnit: Architecting Textile

Sensors with Machine Knitting

Jifei Ou,* Daniel Oran,* Don Derek Haddad,* Joseph Paradiso, and Hiroshi Ishii

Don Derek Haddad Responsive Environments



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ORIGINAL ARTICLE

SensorKnit: Architecting Textile Sensors with Machine Knitting

Jifei Ou,* Daniel Oran,* Don Derek Haddad,* Joseph Paradiso, and Hiroshi Ishii

Abstract

This article presents three classes of textile sensors exploiting resistive, piezoresistive, and capacitive properties of various textile structures enabled by machine knitting with conductive yarn. Digital machine knitting is a highly programmable manufacturing process that has been utilized to produce apparel, accessories, and footwear. By carefully designing the knit structure with conductive and dielectric yarns, we found that the resistance of knitted fabric can be programmatically controlled. We also present applications that demonstrate how knitted sensor can be used at home and in wearables. While e-textiles have been well explored in the field of interaction design, this work explores the correlation between the local knitted structure and global electrical property of a textile.

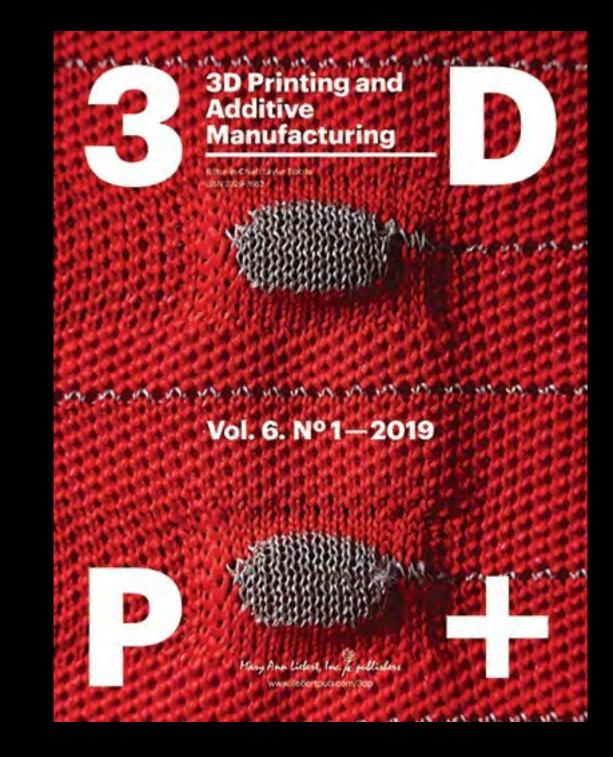
Keywords: digital fabrication, additive manufacturing, textile sensors, machine knitting, material design

Introduction

MATERIALS ARE FUNDAMENTAL in how we interact with the world. Recently, there have been growing interests of fabridditive manufacturing. In particular advancements in fab

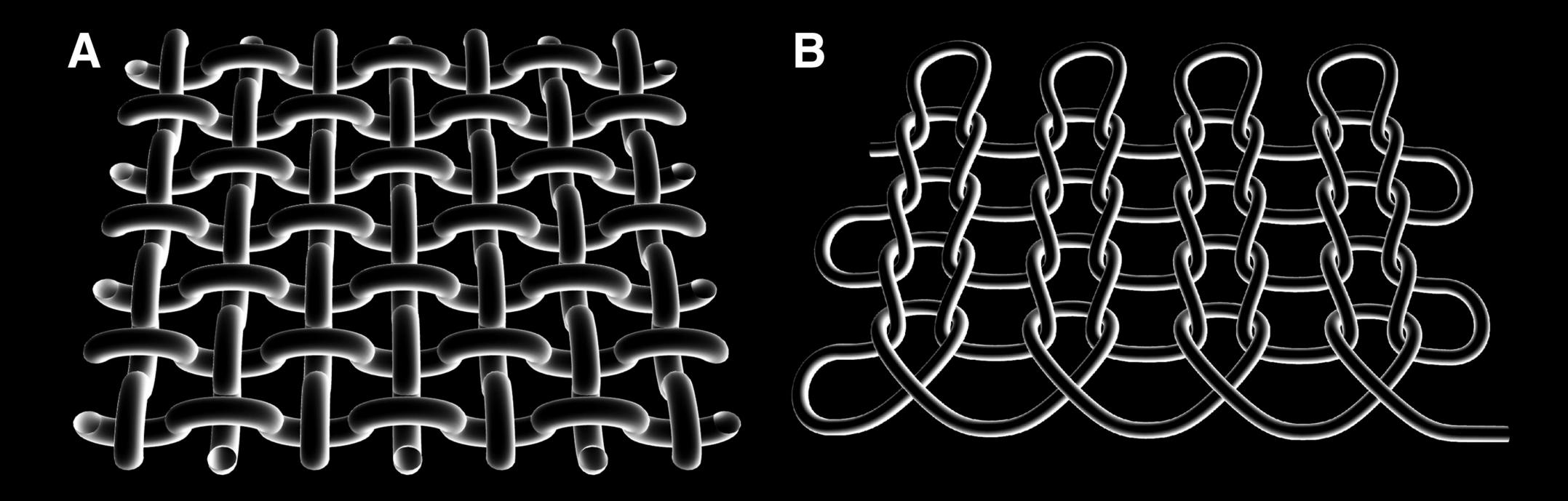
sense, weaving, knitting, and embroidery can be considered additive manufacturing methods for textiles. Twenty years ago, Margaret Orth and her collaborators at

the MIT Media Lab developed Musical Jacket, an interaccating multimaterials in the context of digital fabrication and tive garment with an embedded touch-sensitive keypad connected by conductive yorn ¹⁰ Since then a taxtile has be



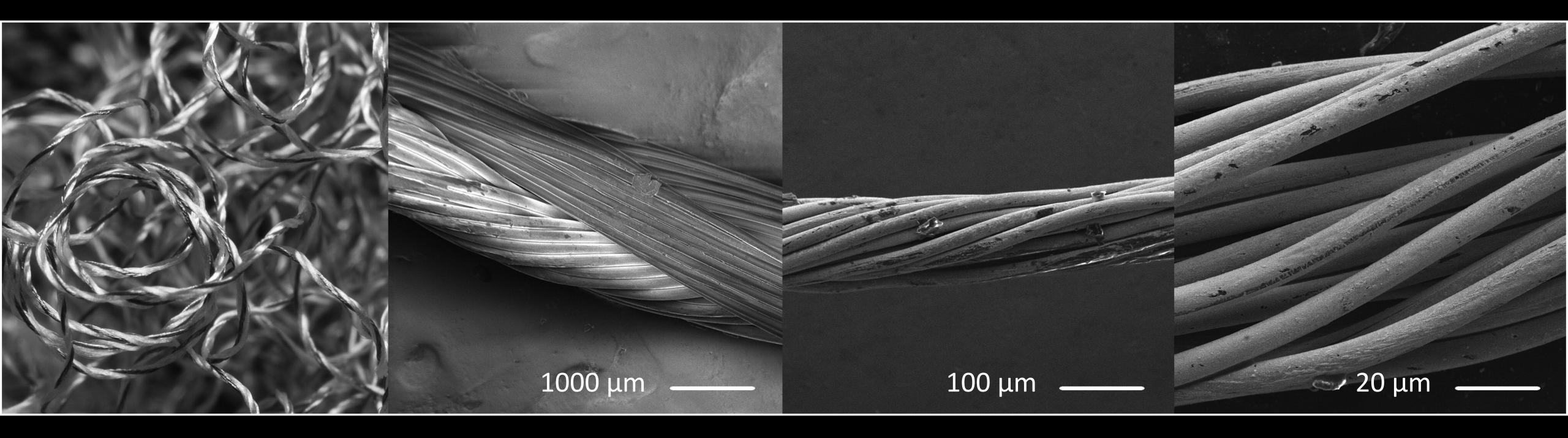
Published at the 3D Printing and Additive Manufacturing Journal https://www.liebertpub.com/doi/pdf/ 10.1089/3dp.2018.0122





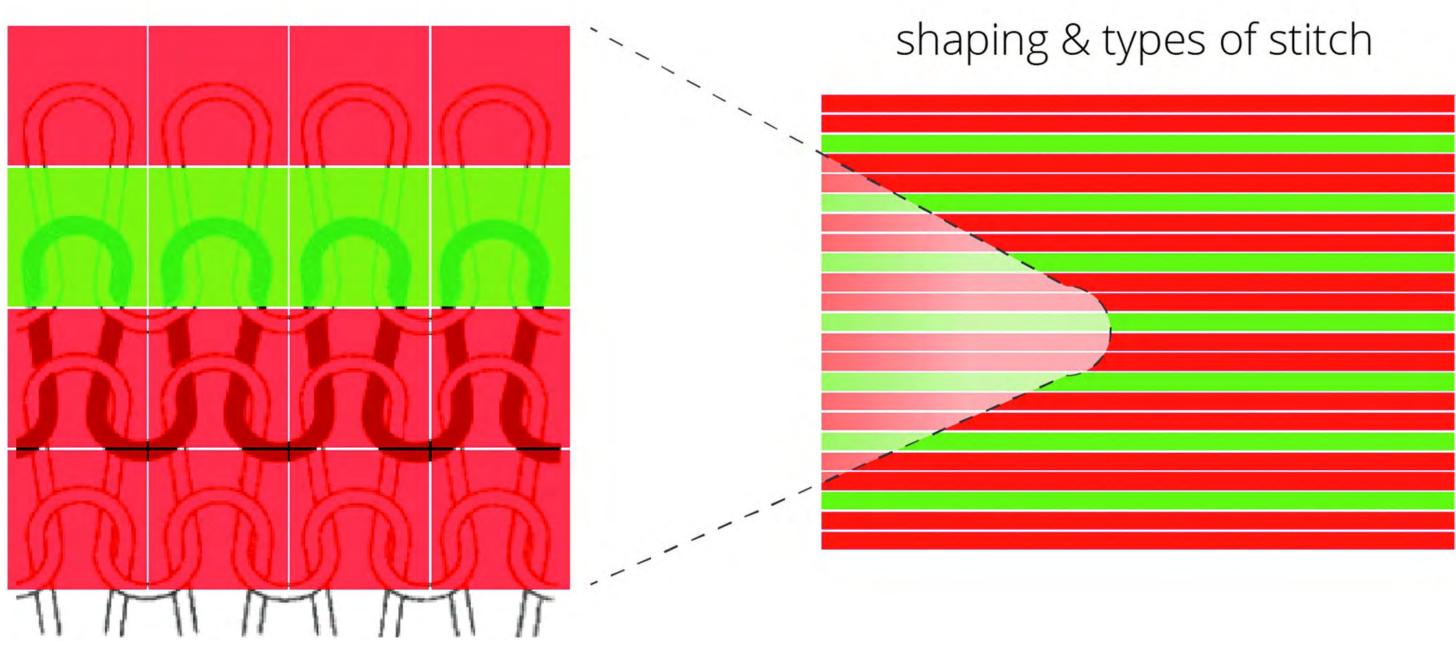
(A) Woven fabric structure, (B) knitted fabric structure.

Conductive thread

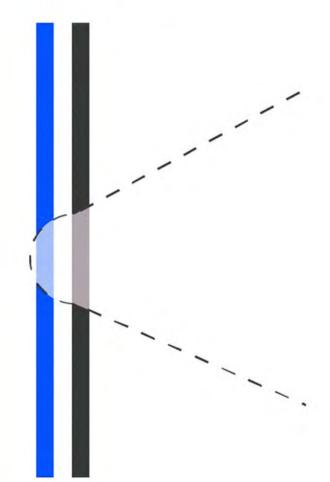


A close inspection to the fibers shows a dielectric core coated with a thin film of silver nanoparticles.

Machine Knitting



machine instruction



use	use
yarn	tension
carrier	setting
4	8

Sensing Modalities and Interactions:

Resistive Stretch Bend Slide Touch

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Capacitive Pressure Touch Proximity

Capacitive Knits





Resistive Knits

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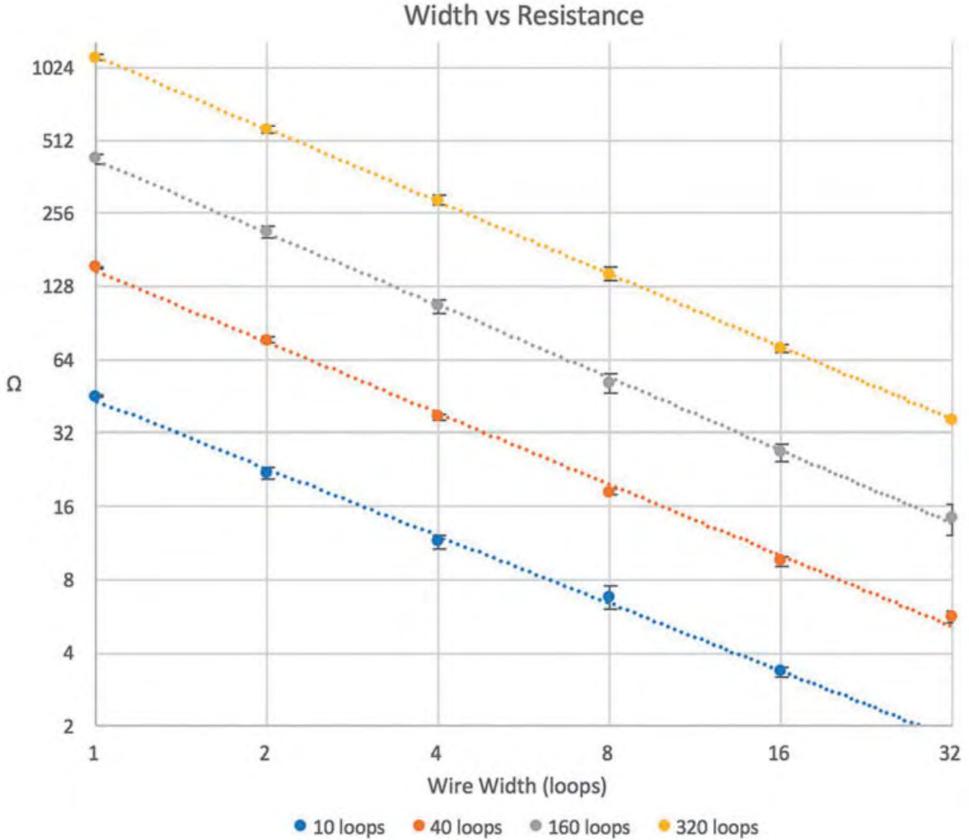


Knit-level conductivity characterization





Knit-level conductivity characterization

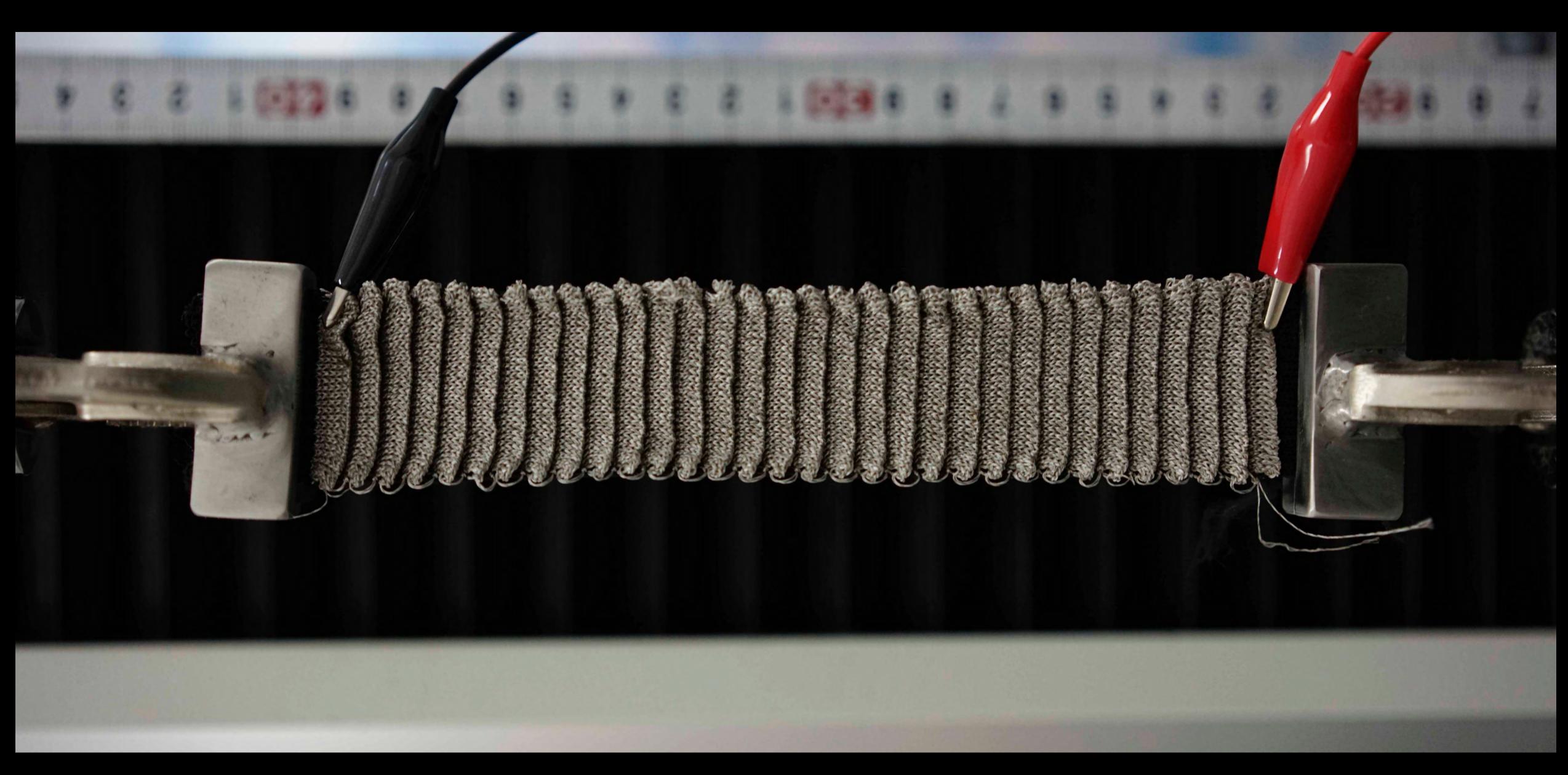


Log base 2 graph describing resistance in relation to loop length and width.

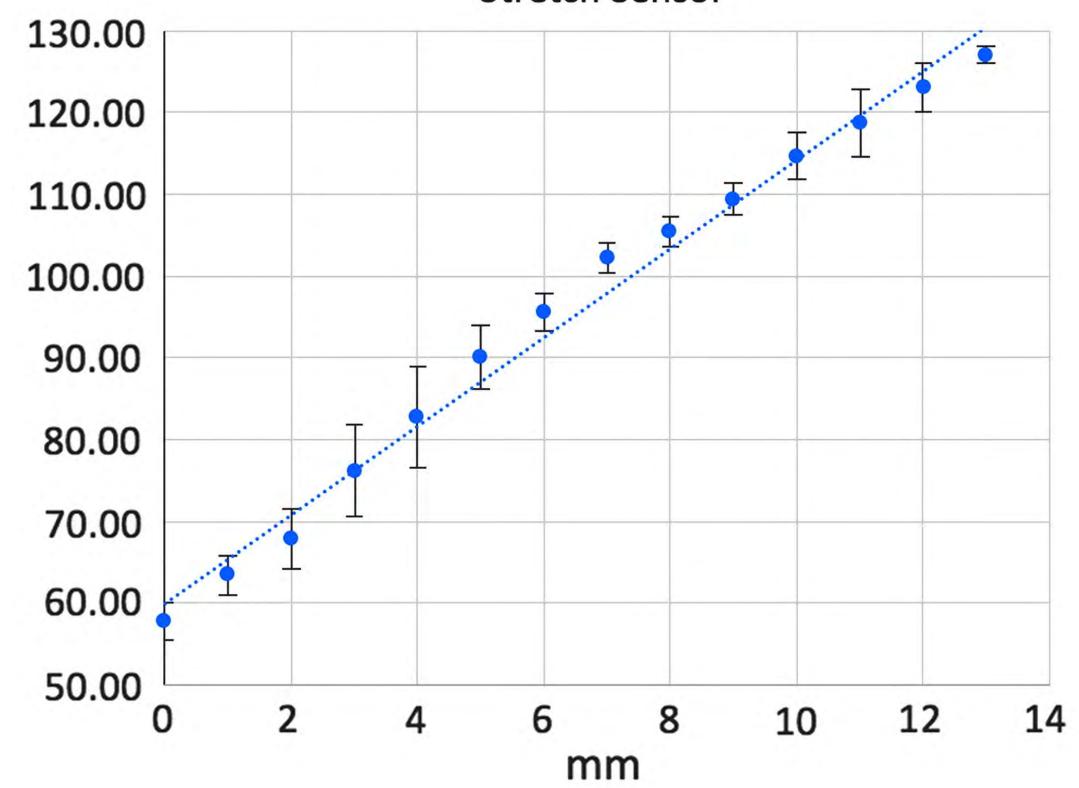
$\mathbf{R} = L^* 2.63^* W^{-1}$

The relation between the loop number in length L and width W to the total Resistance of the structure. The constant **2.63** was calculated based on the characterization test. Given a certain type of conductive yarn, this constant may vary based on the stitch tension.

Stretch Sensor Characterization Test



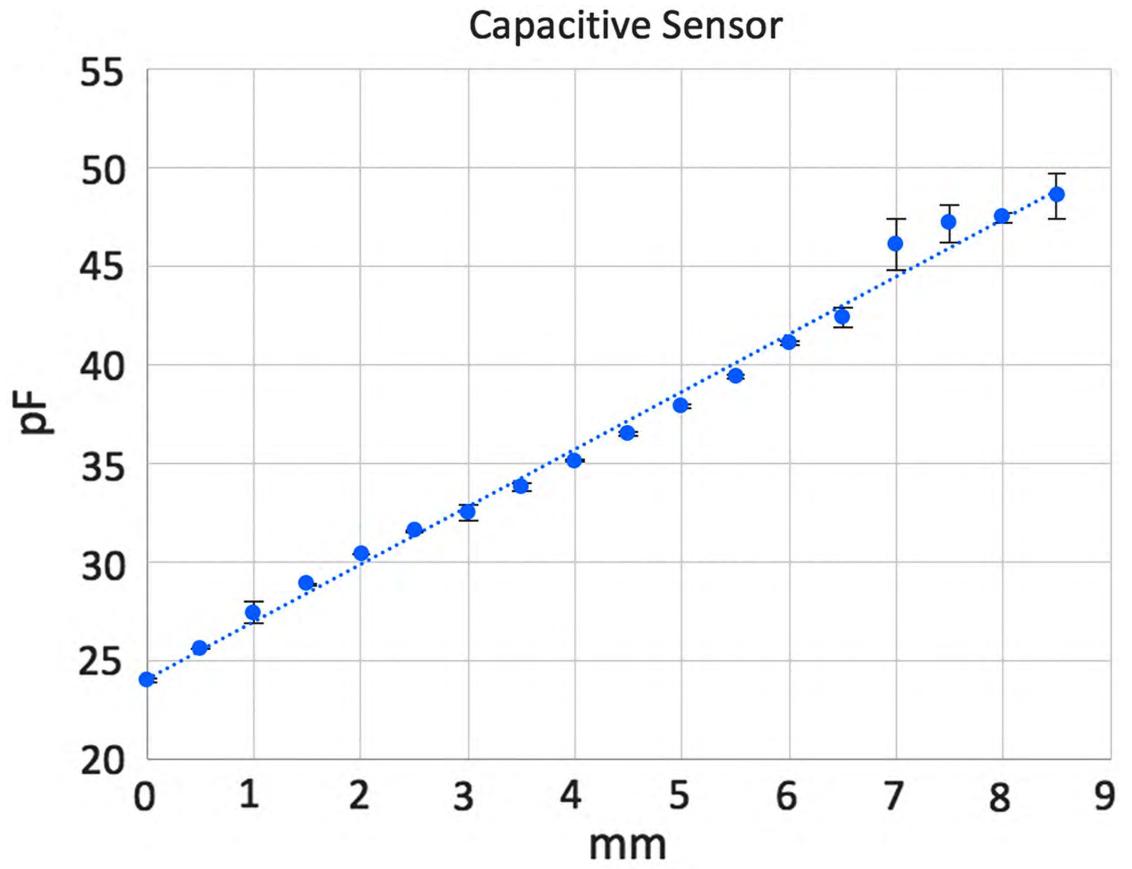
Resistive sensing characterization



Characterization results of 1 mm increments while noting resistance

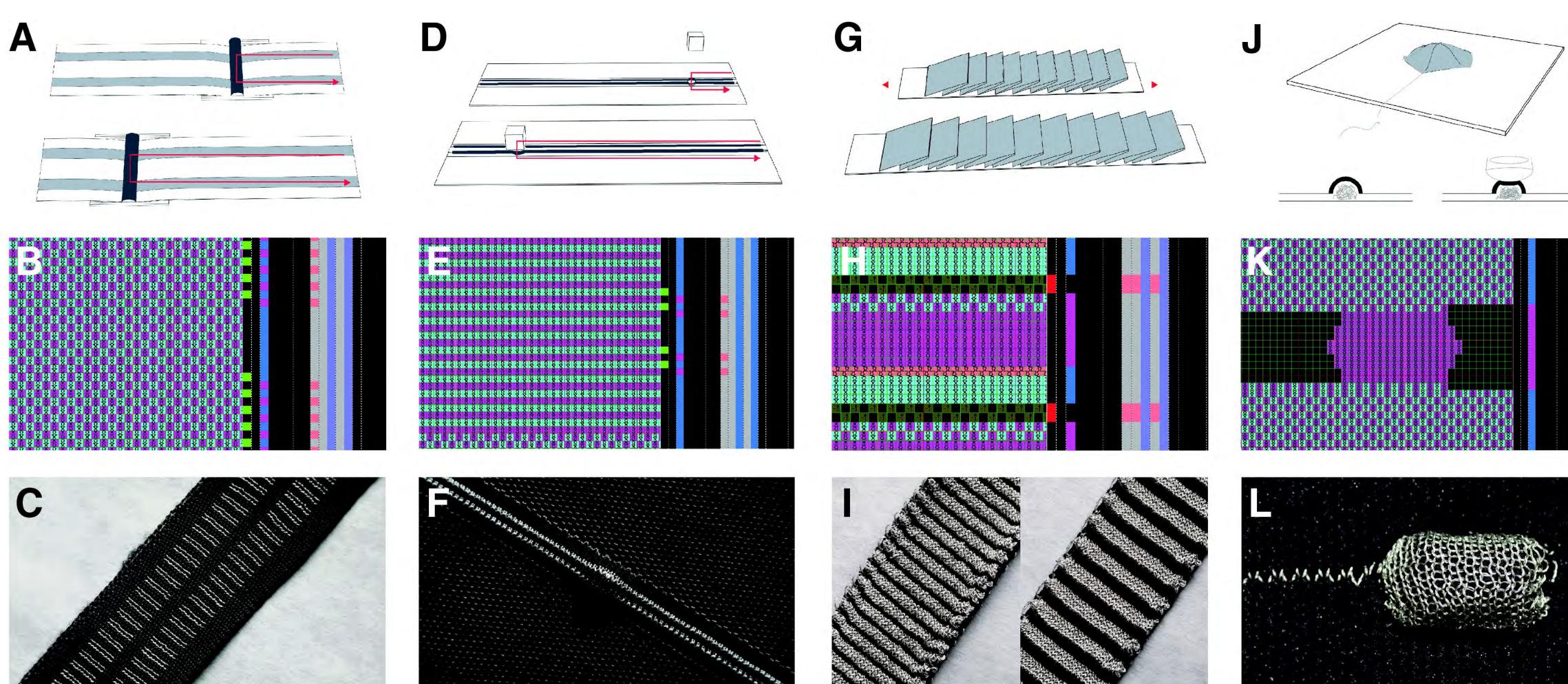
Stretch Sensor

Capacitive sensing characterization

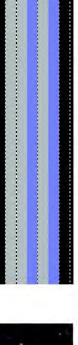


Characterization results of 1 mm increments while noting capacitance.

Design Patterns



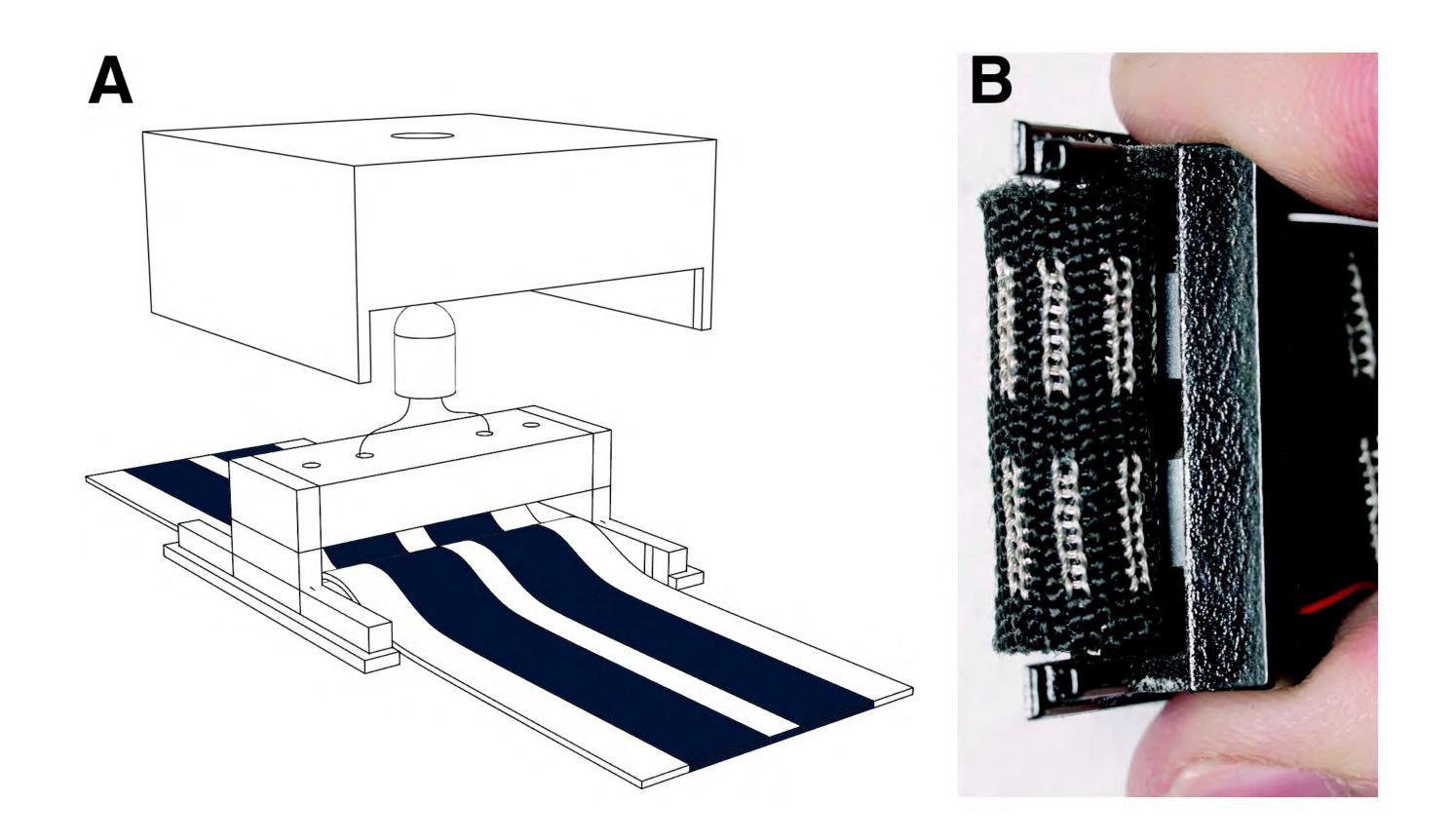
(A–C) Belt rheostat illustration, knit design, and sample photograph. (D–F) Tablecloth rheostat illustration, knit design, and sample photograph. (G–I) Stretch sensor illustration, knit design, and sample photograph. (J–L) Displacement/pressure sensor illustration, knit design, and sample photograph.



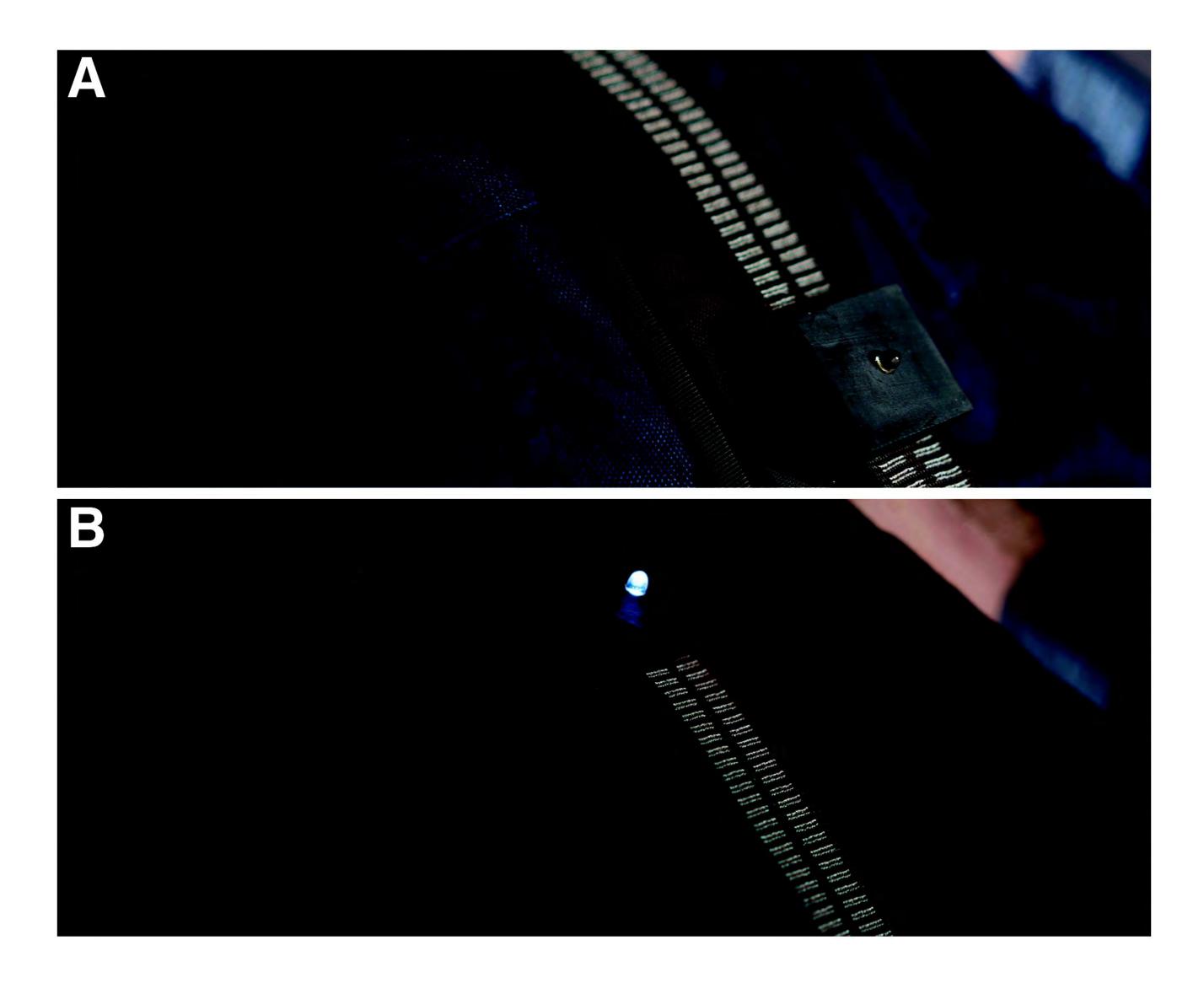




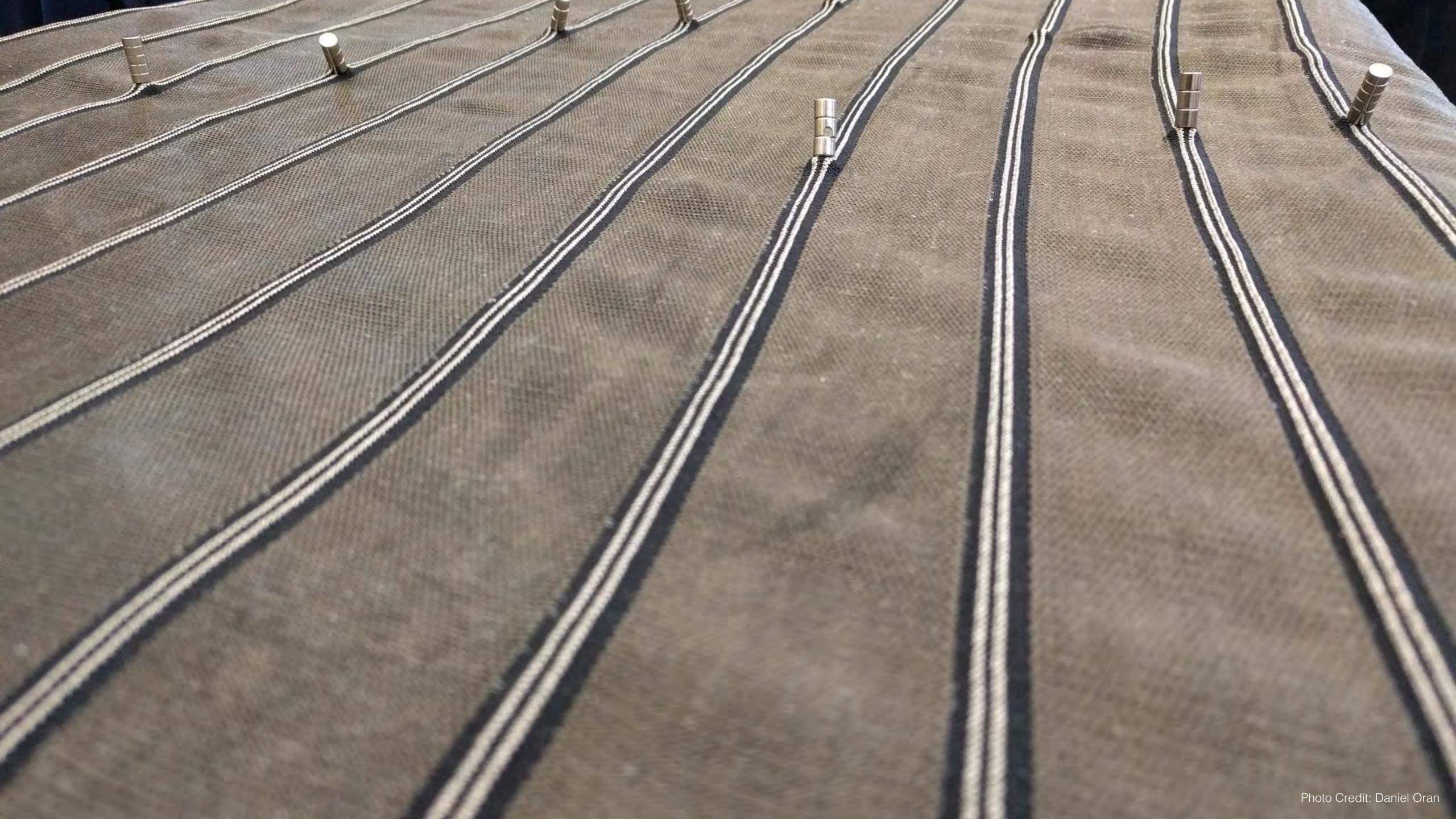
Applications



(A) Structural design of the light buckle. (B) Features the connection mechanism to the belt via two metallic cylinders, one connected to ground and the other to 9 V.



Customized belt rheostat sewn onto a backpack with a 3Dprinted enclosure that covers the buckle, and a voltage divider circuit that changes the brightness of an LED; (A) low brightness, (B) high brightness.











Building and Deploying the Networked Sensory Landscape



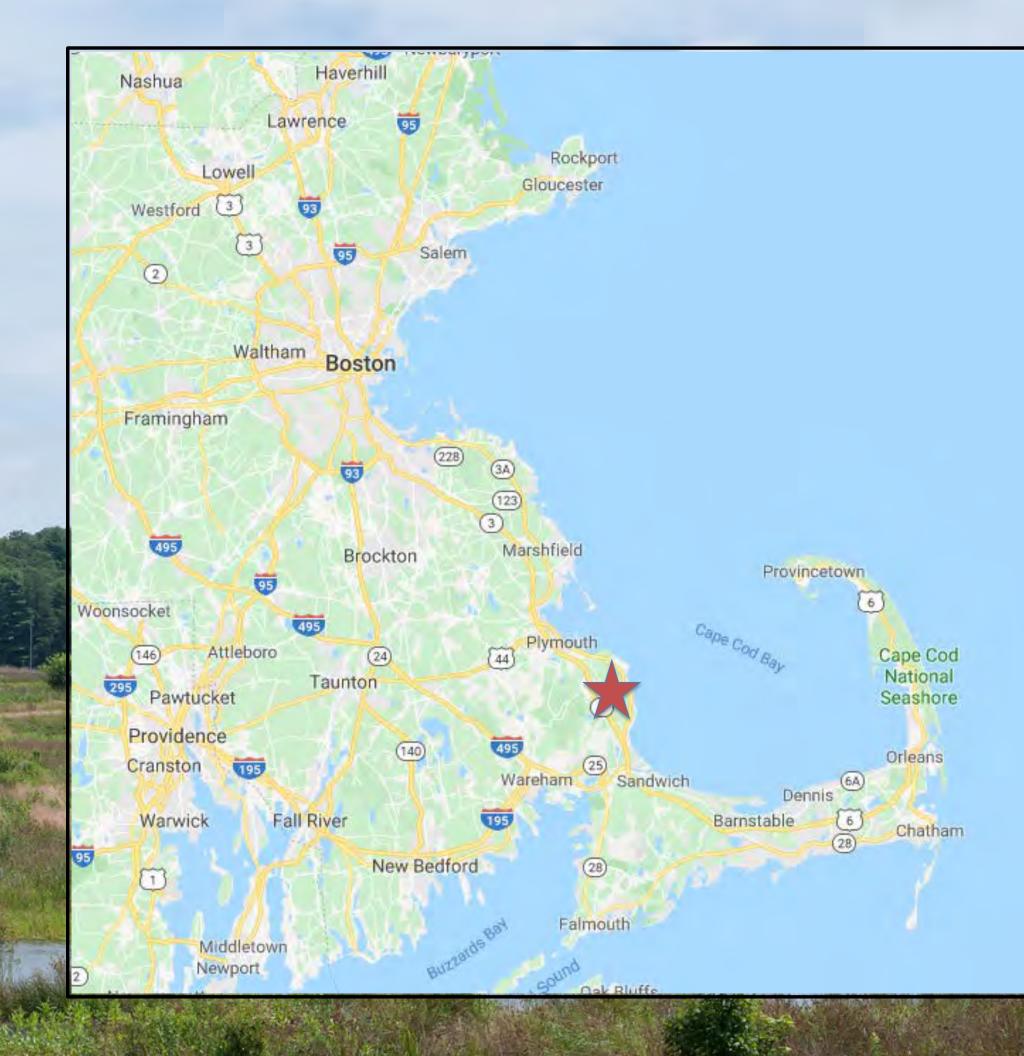
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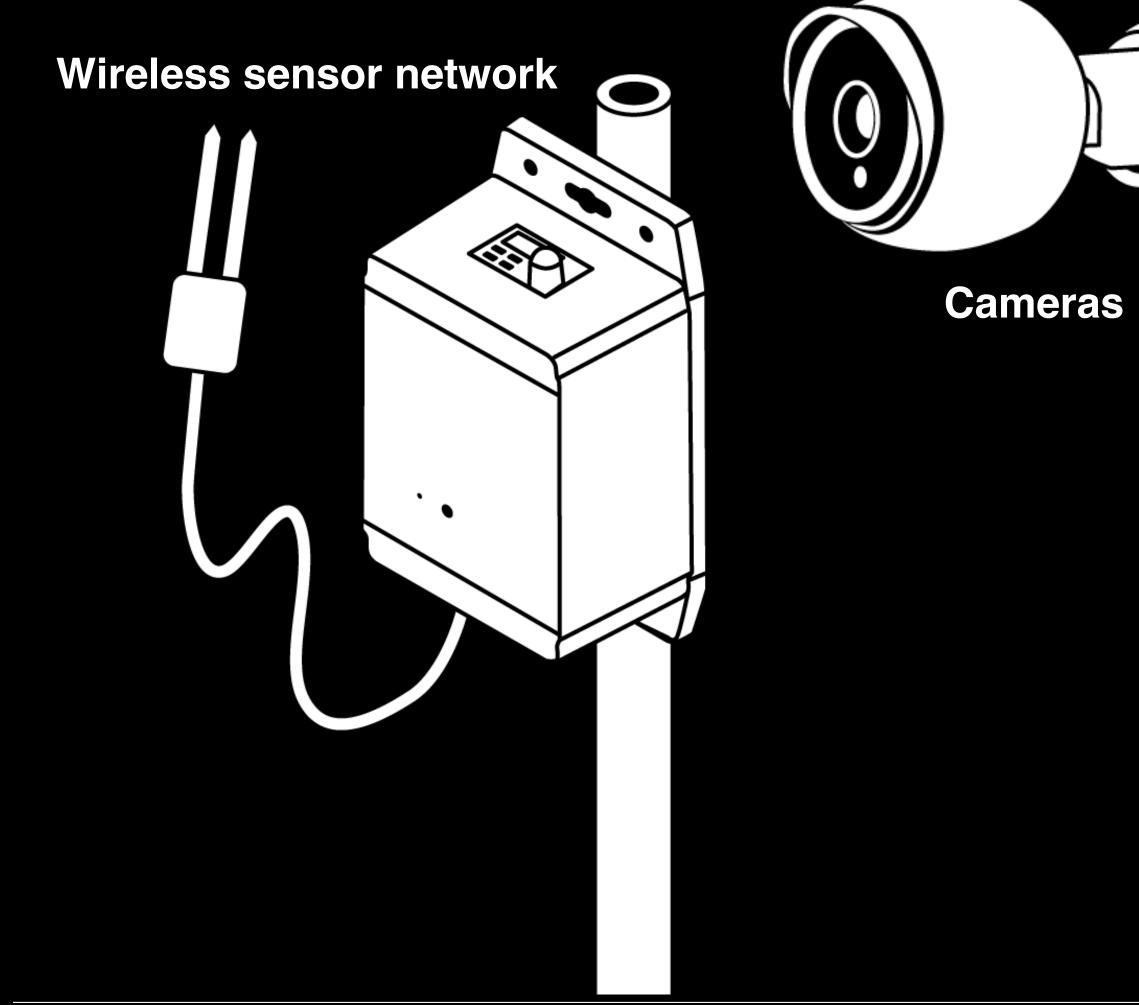


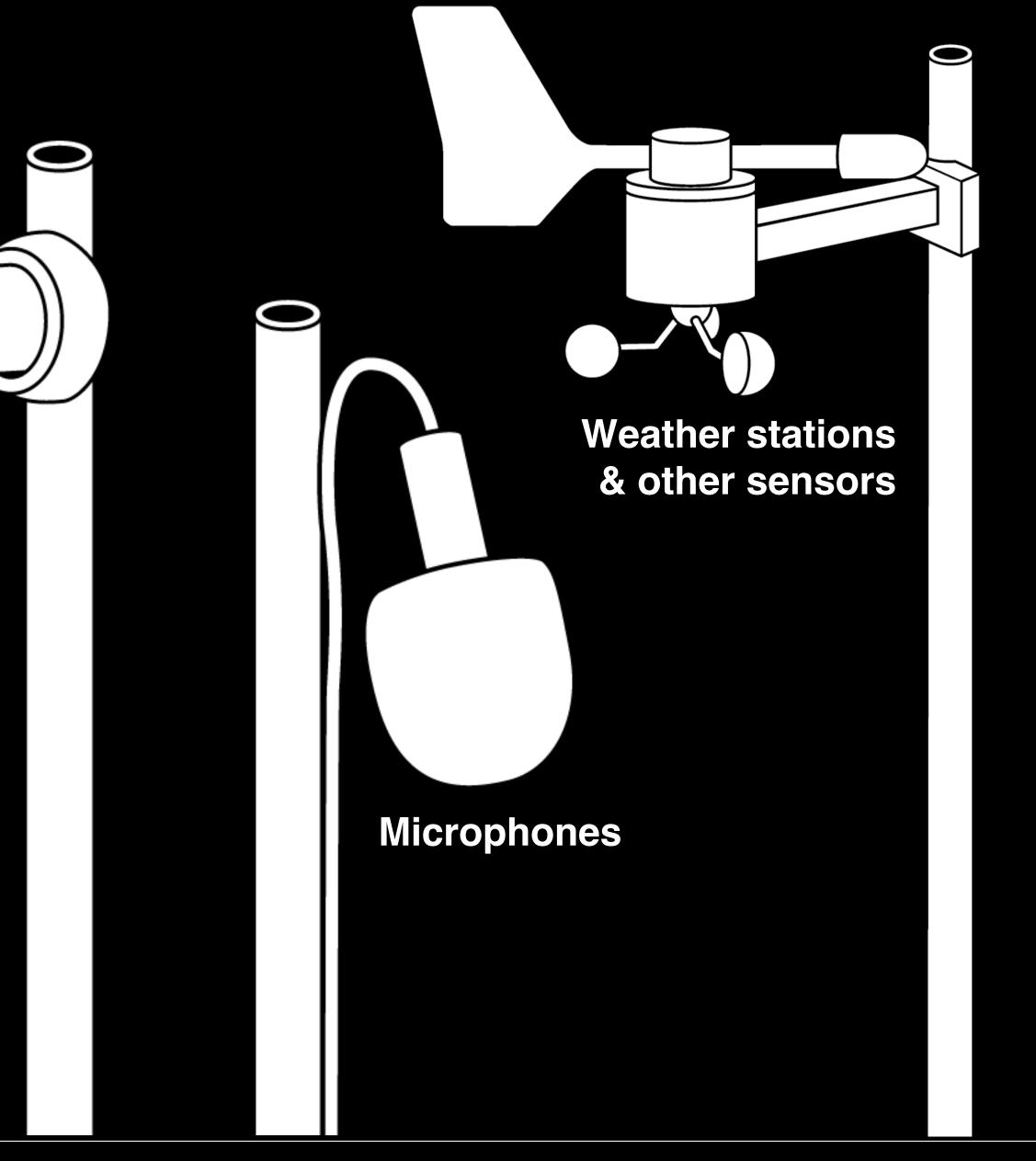






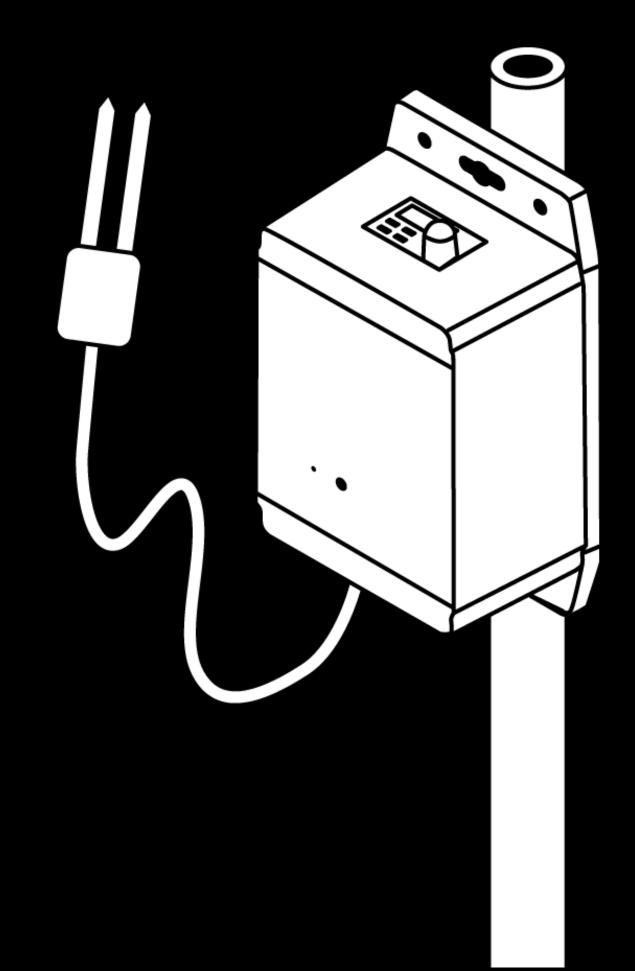


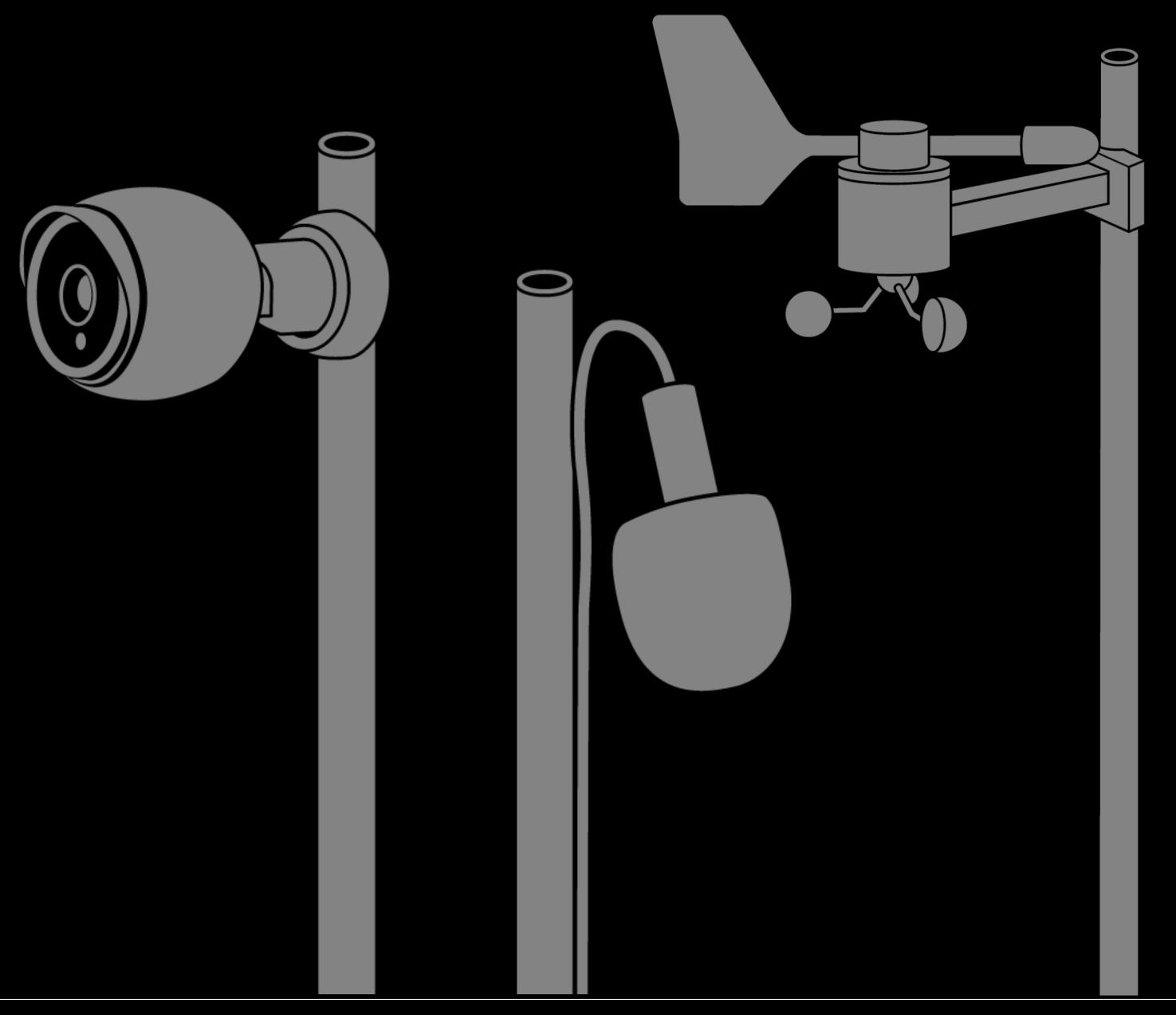




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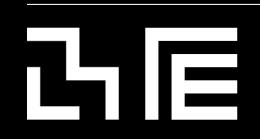


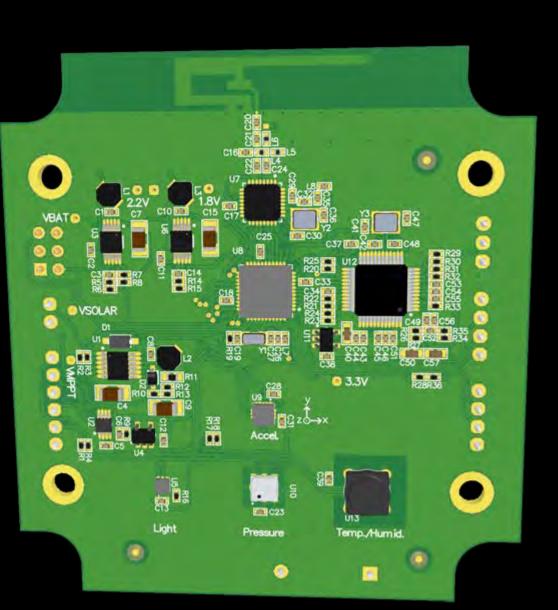
The Sensing Platform, mark I



- Temperature
- Humidity
- Atmos. Pressure
- Visible Light
- Accelerometer

~2 year battery life







The Sensing Platform, mark II



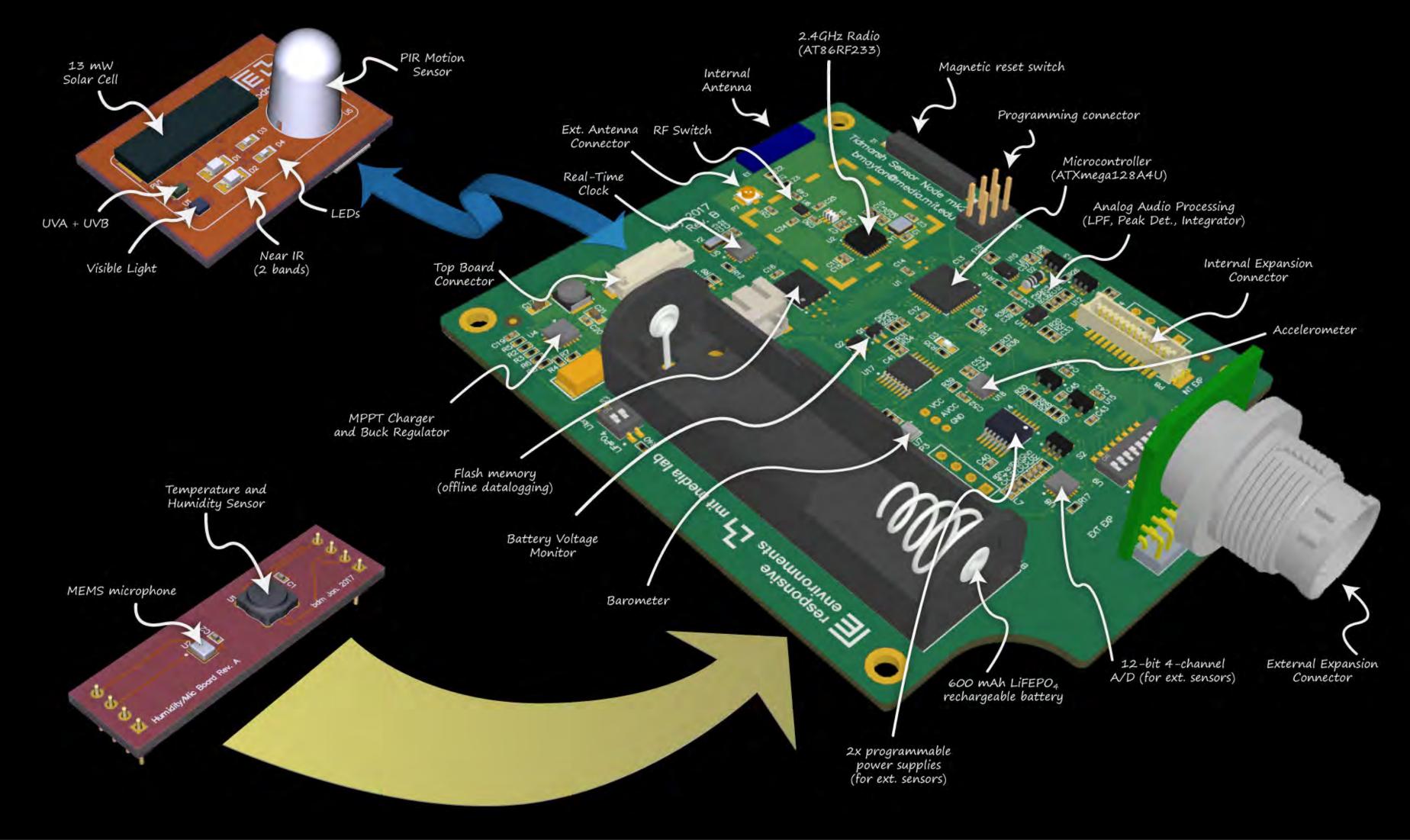
- Temperature ightarrow
- Humidity ightarrow
- Atmos. Pressure
- Visible Light ightarrow
- Ultraviolet (UVA + UVB)
- Infrared ightarrow
- **PIR** motion ightarrow
- Audio levels/FFT ightarrow
- Accelerometer ightarrow
- Indefinite lifetime (with sun) ~ 1 year battery life (no sunlight)
- ightarrowullet

- Up to 4 analog channels, \bullet 0-3V range with signal conditioning
- 2 programmable voltage outputs
- Onewire, I2C, UART





The Sensing Platform, mark II





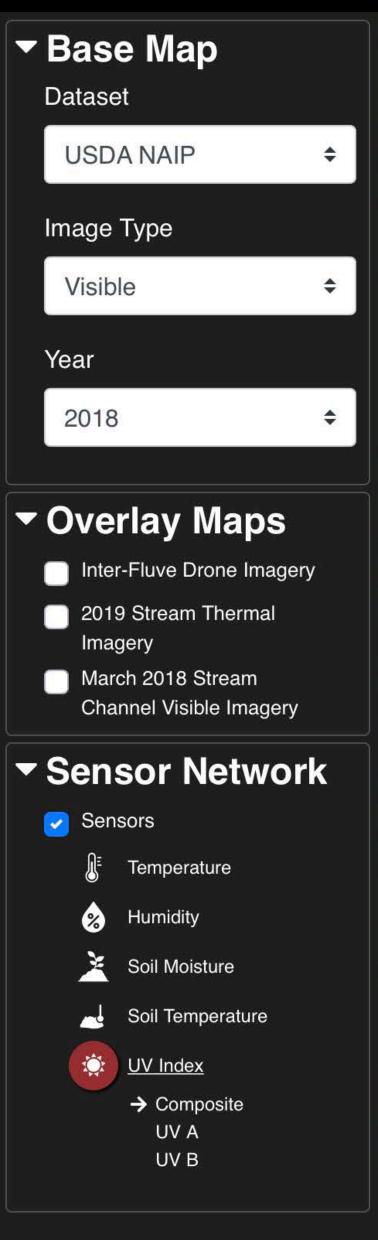


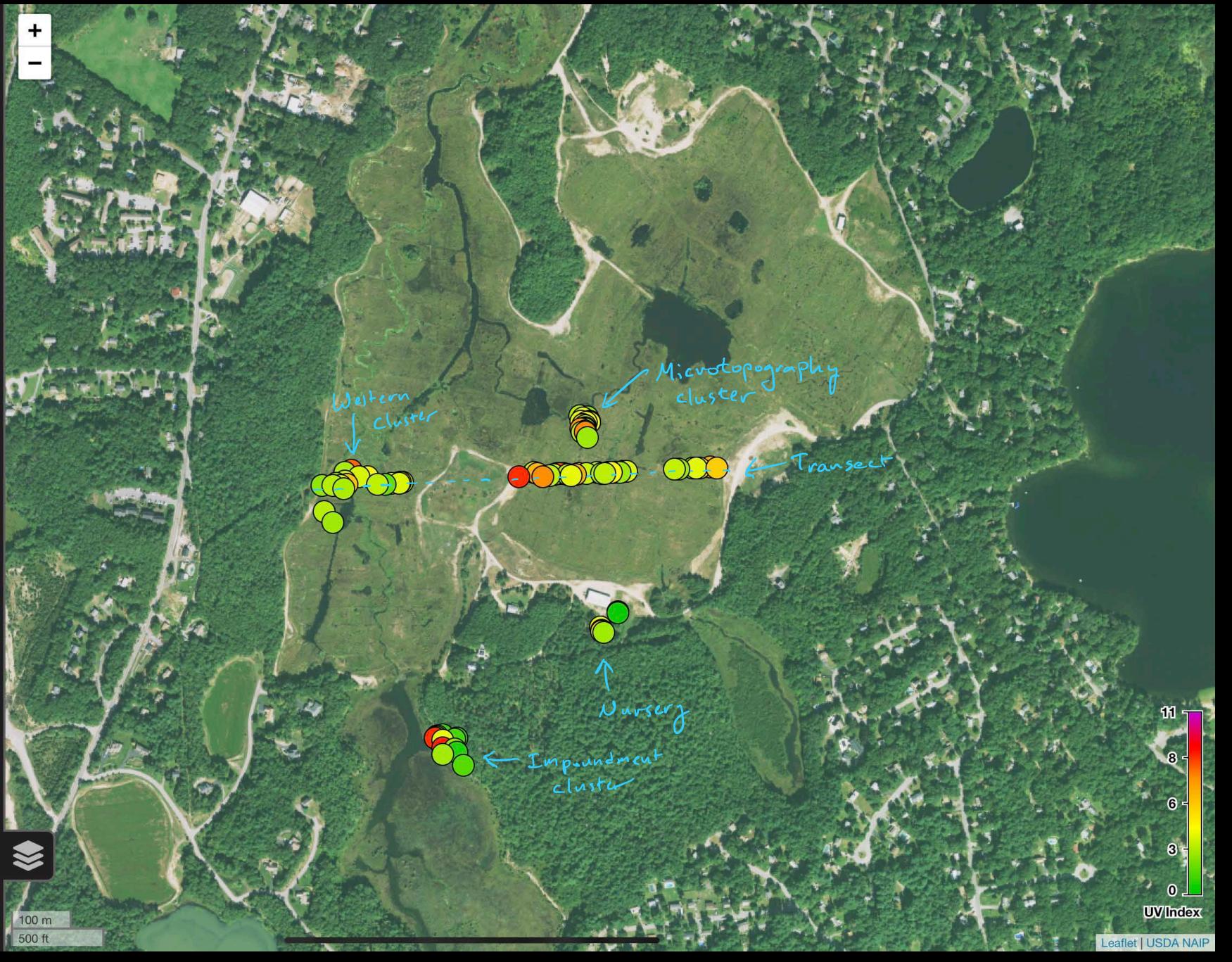


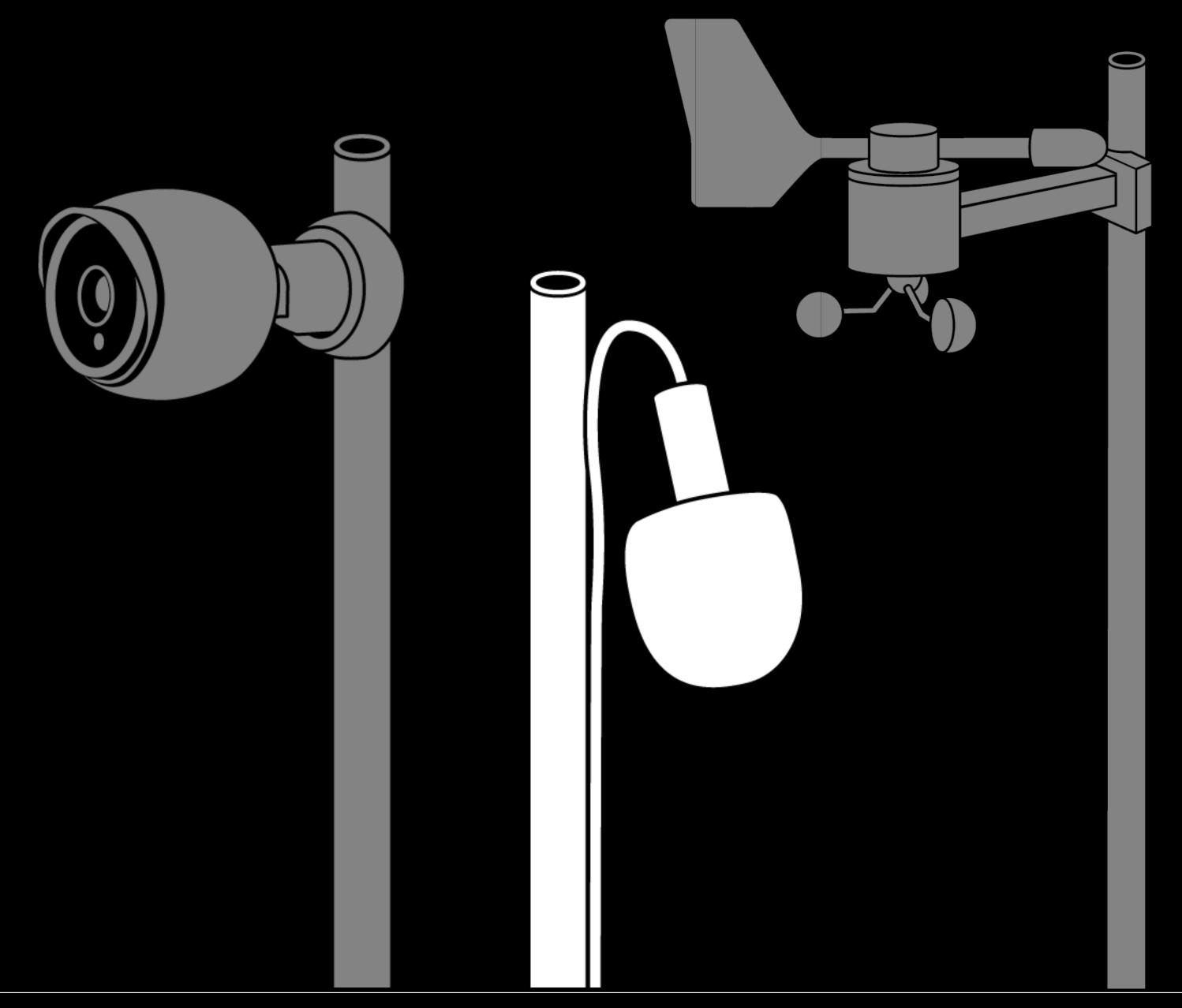


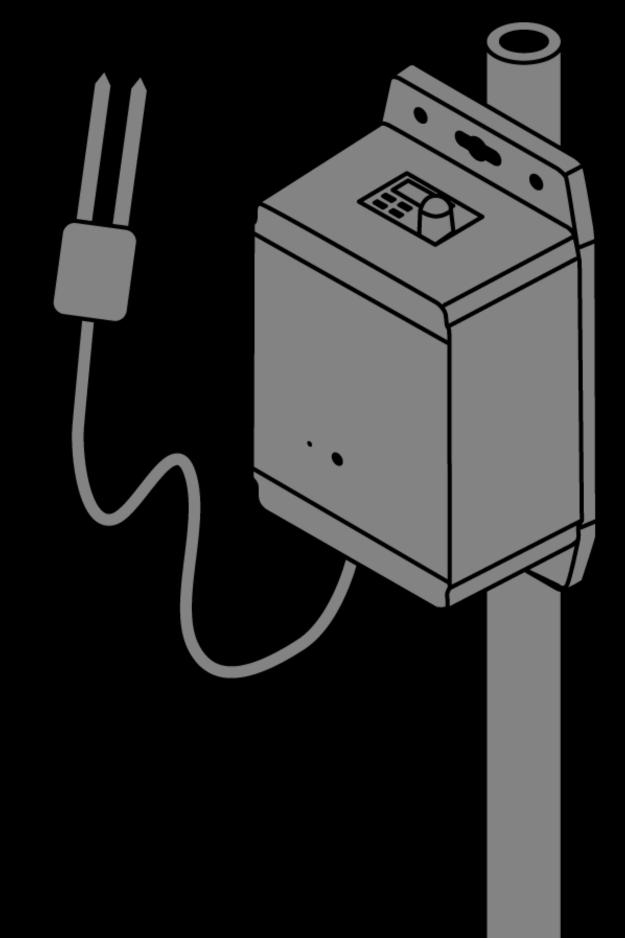














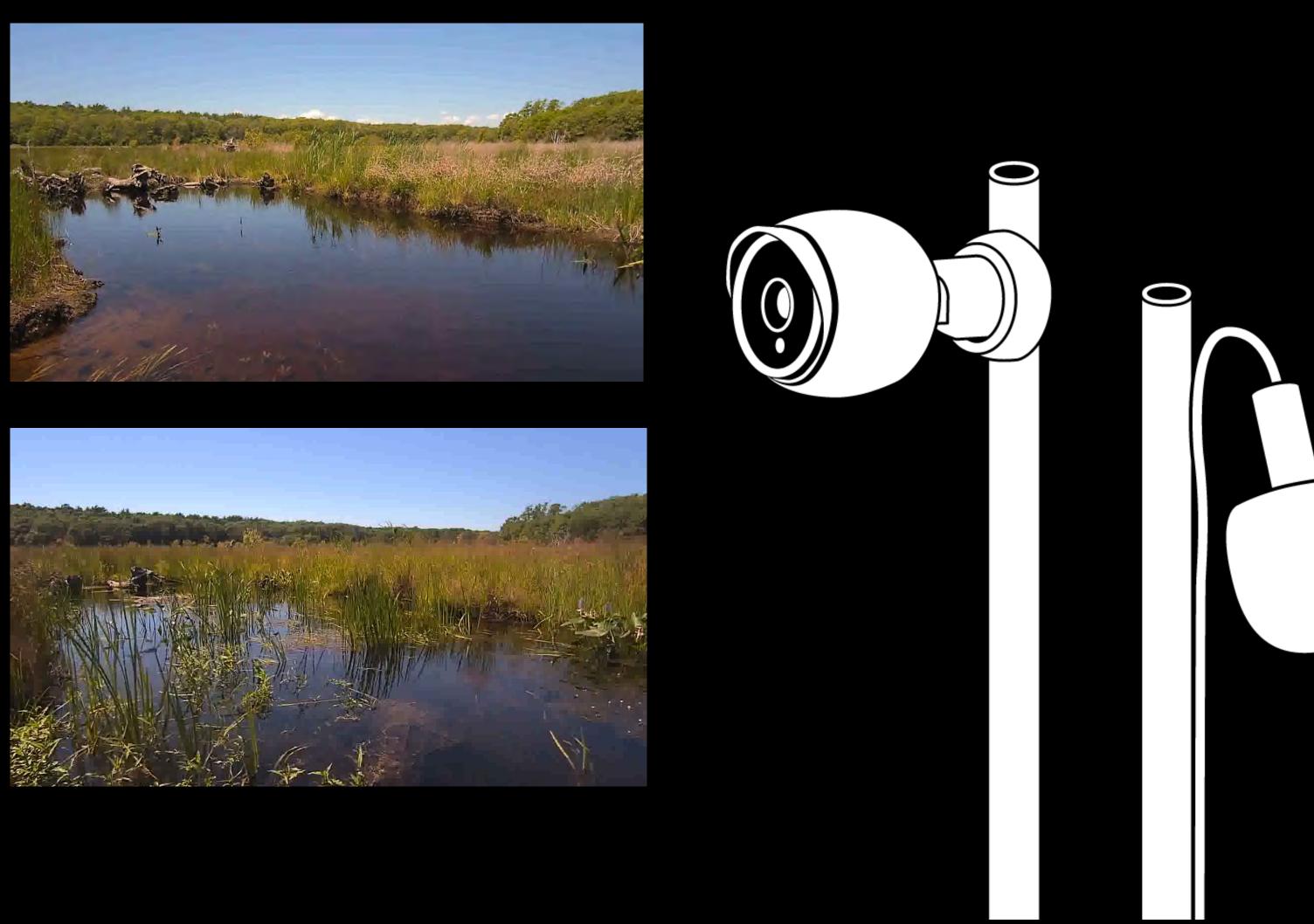




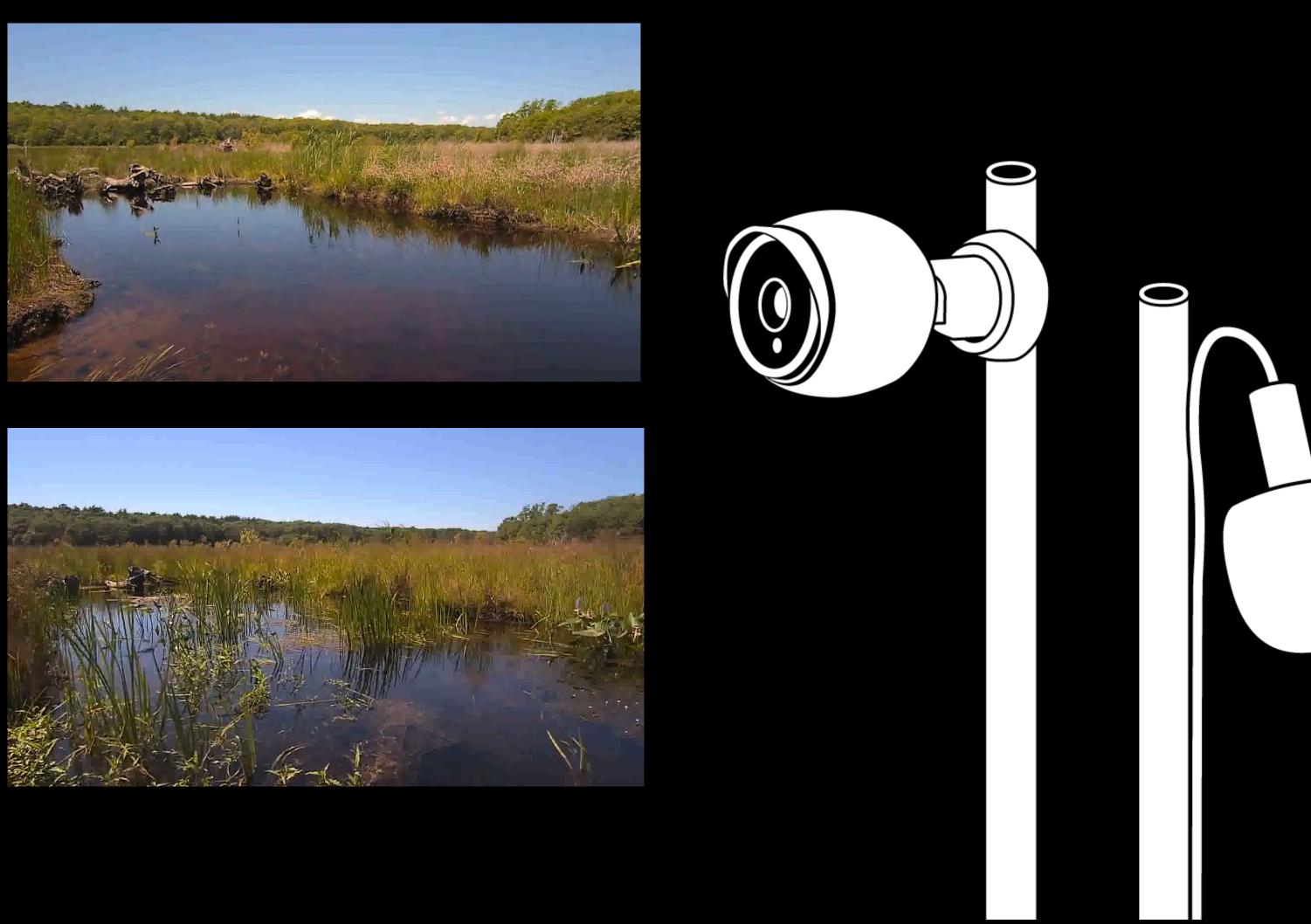


Cameras & Microphones





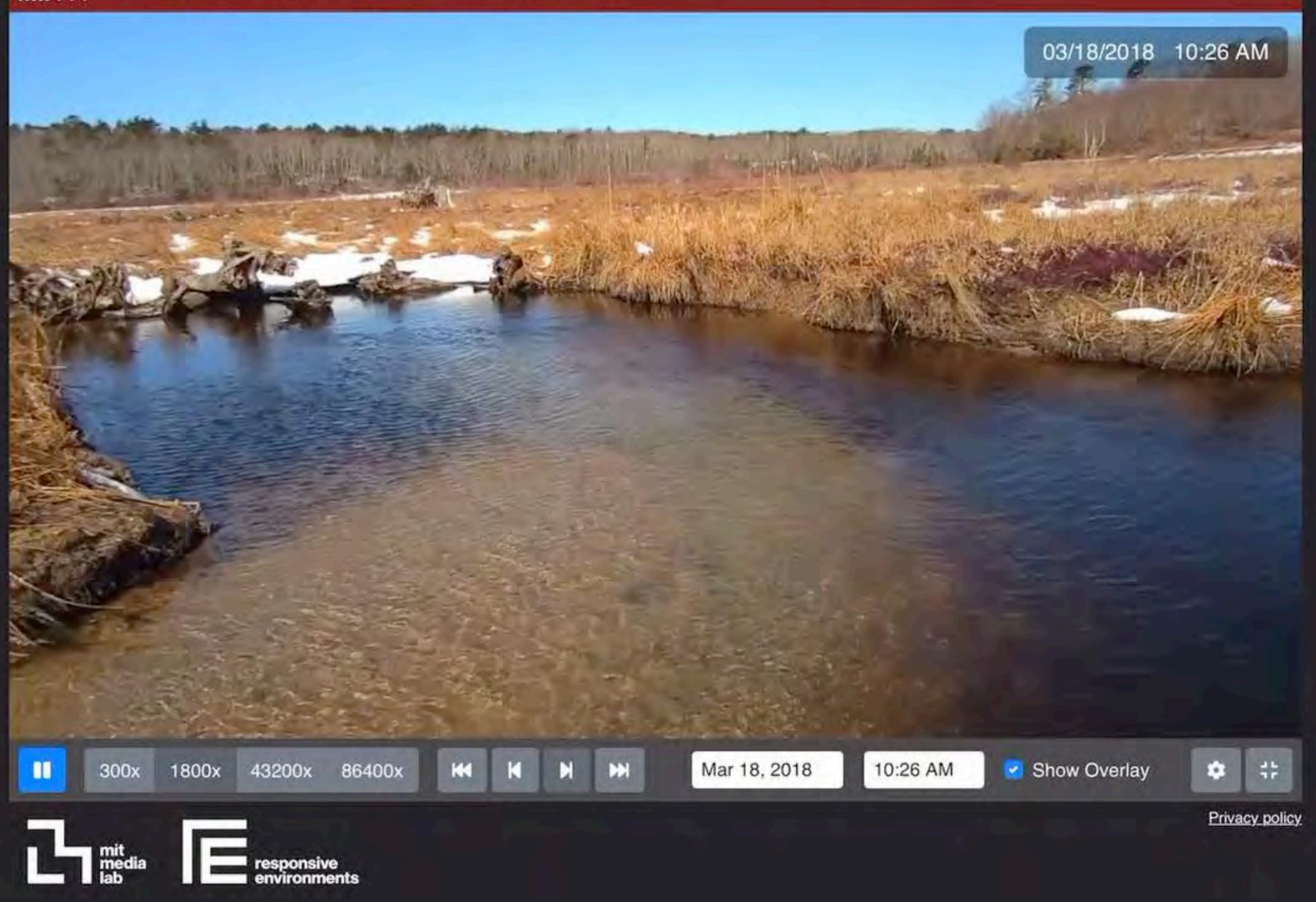




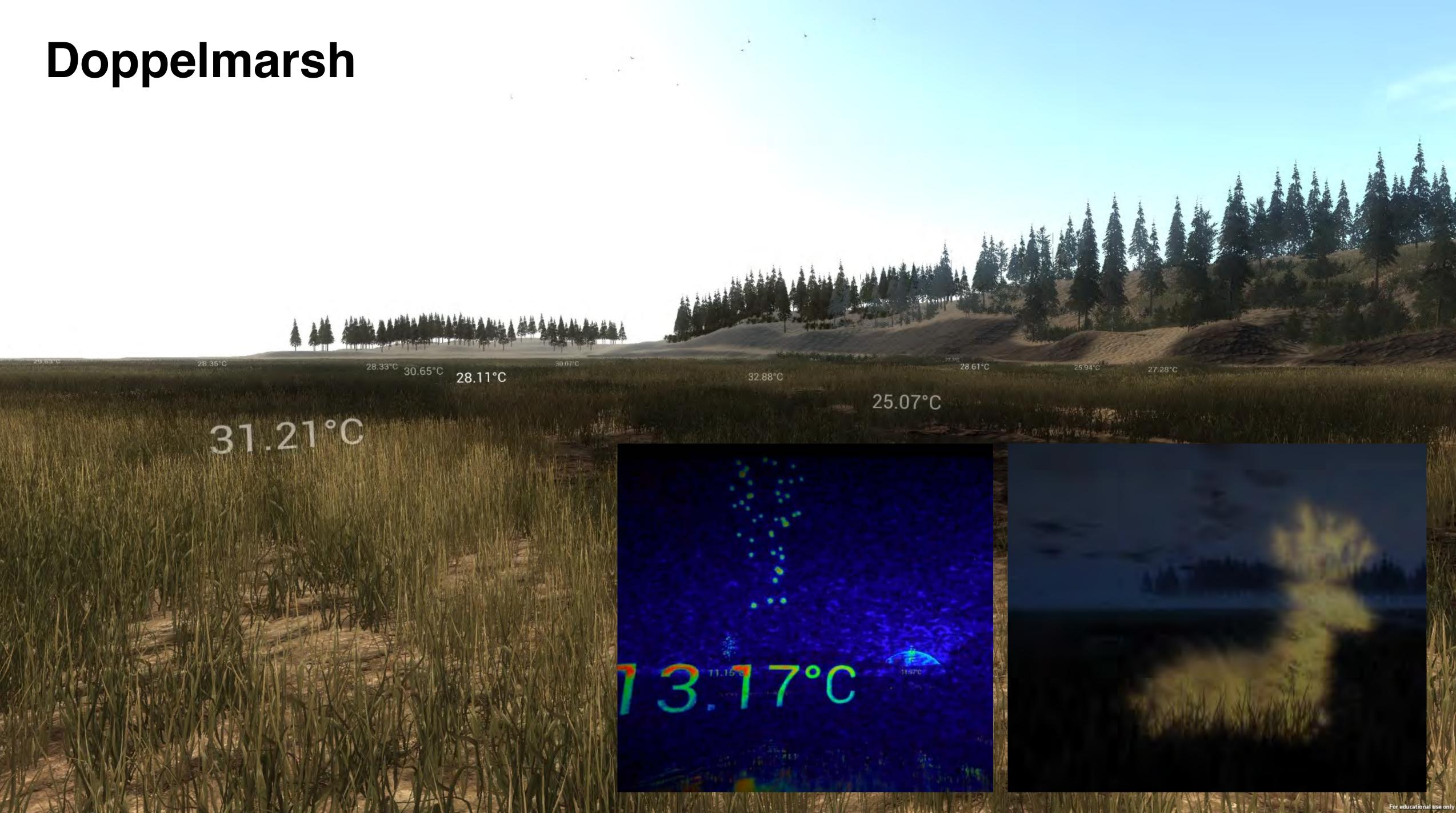






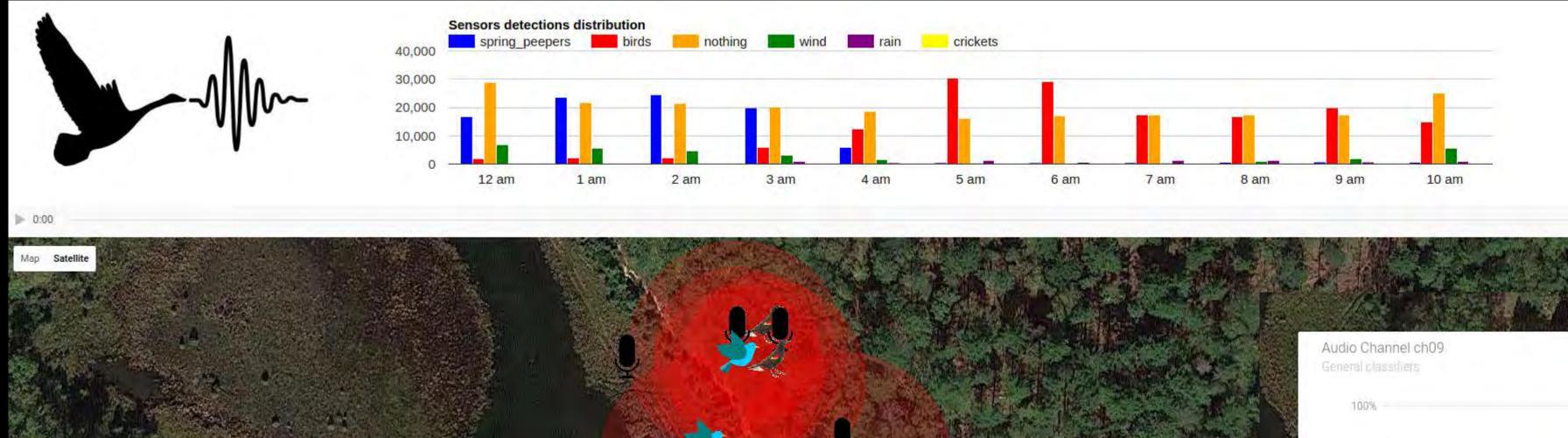




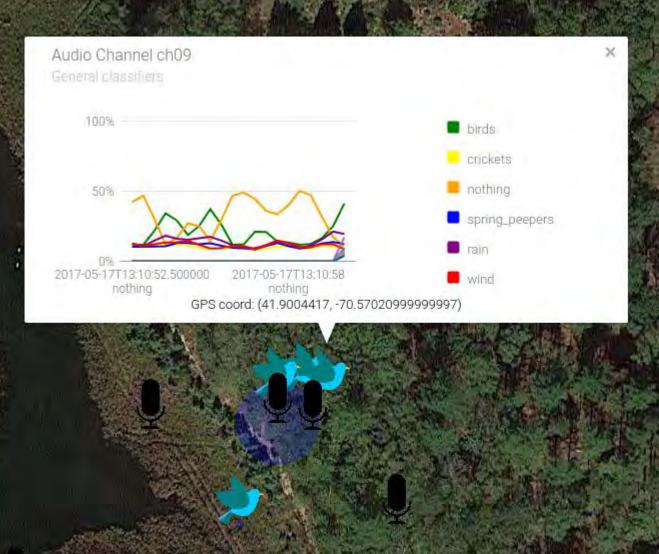




Tidzam



http://tidzam.media.mit.edu





hear - there

Bone conduction - - - - - Head tracking, touch, EEG

Network, AI - - - - -



